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Management 6th Edition By James A F Stoner R Edward Freeman.1. Field of the Invention The present invention relates to a substrate processing apparatus which includes a plasma processing system, particularly relates to a substrate processing apparatus which includes a gas supply system for supplying process gas from a vacuum chamber to a vacuum chamber. 2. Description of the Related Art There are a large number of plasma processing apparatuses which include a vacuum chamber for processing a substrate, a gas supply system for supplying process gas to the vacuum chamber, a gas exhaust system for exhausting process gas from the vacuum chamber, a power supply for applying a power to the vacuum chamber, a substrate processing system for performing the predetermined process using plasma generated by the power applied to the vacuum chamber, and the like. The plasma processing apparatus is used as an example of a processing system of a semiconductor manufacturing equipment. In the plasma processing apparatus, it is necessary to keep the pressure in the vacuum chamber substantially the same as the pressure of the atmosphere in order to maintain the predetermined condition for generating the plasma. Accordingly, the gas supply system to supply process gas is provided between the vacuum chamber and the atmosphere to keep the pressure in the vacuum chamber substantially the same as the pressure of the atmosphere. The gas exhaust system is also provided between the vacuum chamber and the atmosphere to take away waste gas (vacuum decomposition gas) generated in the vacuum chamber. The gas supply system is provided in a configuration of a gas supply pipe in which a pipe valve to open/close the gas supply pipe and a pipe valve which provides communication between the vacuum chamber and the gas supply pipe are provided. Further, the gas exhaust system is provided in a configuration of an exhaust pipe in which a pipe valve to open/close the exhaust pipe and a valve to provide communication between the gas exhaust pipe and an exhaust pump are provided. In the case of using the pipe valve to open/close the gas supply pipe and the pipe valve to open/close the exhaust pipe in this manner, when a vacuum valve to open/close the pipe valves to the atmosphere is operated in accordance with the process conditions, one of two pipe valves is opened, and the other is closed. Therefore, the gas supply pipe is opened, and the gas exhaust pipe is opened/closed. When the gas supply pipe and the gas exhaust pipe are opened/closed in this manner, the flow rate of the gas flowing into the vacuum chamber from the gas supply pipe is large, and the flow rate of the



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